

U.S. Department of Commerce, Patent and Trademark Office					Attorney Docket No.		Serial No.	
					DC-03112		10/688,237	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant(s)			
(Use several sheets if necessary)					Munif Farhan Halloush, et al.			
					Filing Date		Group	
					October 18, 2003		2655	
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	2003/0021201 A1	Jan. 30, 2003	Kobayashi	369	47.39		
	AB	2003/0058765 A1	Mar. 27, 2003	Schreurs et al.	369	47.53		
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL	KR2003069706	Aug. 27, 2003	Republic of Korea	G11B	7/004	<input type="checkbox"/>	<input type="checkbox"/>
	AM	KR2002096641	Dec. 31, 2002	Republic of Korea	G11B7	7/125	<input type="checkbox"/>	<input type="checkbox"/>
	AN						<input type="checkbox"/>	<input type="checkbox"/>
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AR	Ohkubo, S. et al. "Optimization of Write Strategy in a PRML System for High Density Recording" International Symposium on Optical Memory and Optical Data Storage Topical Meeting, July 7-11, 2002, Pages 425-427						
	AS							
	AT							
Examiner			Date Considered					
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